



#19/ID
d. Paul
5/15/03
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TADAHIRO OHMI ET AL.) Examiner: Davienne N. Monbleau
Application No.: 09/425,015) Group Art Unit: 2828
Filed: October 25, 1999)
For: GAS SUPPLY PATH)
STRUCTURE, GAS SUPPLY)
METHOD, LASER)
OSCILLATING)
APPARATUS, EXPOSURE)
APPARATUS, AND DEVICE)
PRODUCTION METHOD) May 5, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The concise explanation of relevance for the non-English documents, JP Nos. 2-241074, 4-032281 and 64-68984 and WO Nos. 90/13160 and 88/07272, may be found in the accompanying English abstracts.

05/09/2003 HDEMESS1 00000069 09425015

02 FC:1806

180.00 DP



The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/538,284	3/30/2000	2828

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2).

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 24947

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